

FORM HDP-1449 (Based on Form PTO-1449)		ATTORNEY DOCKET NO.	SERIAL NO.
		7784-000425DVA	Not Yet Assigned
		APPLICANT	
		Minas H. Tanielian	
		FILING DATE	GROUP 3729
		Herewith	Not Yet Assigned

**PATENT AND TRADEMARK OFFICE**  
**INFORMATION DISCLOSURE CITATION**  
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Sheet 1 of 2

#### U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.	TN	3,456,134	7/15/1969	Ko		
2.		3,466,473	9/9/1969	Rhoten		
3.		3,553,588	1/5/1971	W. Honig		
4.		3,624,451	11/30/1971	Gauld, et al.		
5.		4,467,236	8/21/1984	Kolm et al.		
6.		4,510,484	4/9/1985	Snyder		
7.		5,463,374	10/31/1995	Mendez et al.		
8.		5,751,091	5/12/1998	Takahashi		
9.		5,801,475	9/1/1998	Kimura		
10.		6,306,773	10/23/2001	Adas et al.		
11.		6,382,026 B1	5/7/2002	Tajika et al.		
12.		6,407,484	5/12/1998	Takahashi		
13.	TN	6,530,276 B2	3/11/2003	Tajika et al.		

#### FOREIGN PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes	Translation No
1.	TN	2 026 284	7/17/1979	UK			
2.	TN	2 064 883	11/25/1980	UK			

Examiner:

Mac Nguyen

Date Considered:

6/28/04

EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Sheet 2 of 2

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	
1.	TN	F. J. von Preissig and E.S. Kim, Topics in Finite-Element Modeling of Piezoelectric MEMS.
2.		Ibong Jung and Yongrae Roh, Design and fabrication of piezoceramic biomorph vibration sensors, Sensors and Actuators A 69 (1998) pp. 259-266.
3.		John Kymmissis, Clyde Kendall, Joseph Paradiso, Neil Gershenfeld, "Parasitic Power Harvesting in Shoes", 8/1998, p. 1-8.
4.		Kloepel, James E., Residual stress in piezoelectric ceramics can be reduced, put to work, News Bureau, (Sept. 1, 2000).
5.	TN	Meteer, Jami, Front-Side Processing of a Piezoelectric MEMS Accelerometer, The Pennsylvania State University National Nanofabrication Users Network, pp. 48-49.

Examiner: Lee Nguyen Date Considered: 6/28/04

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Sheet 1 of 1

ATTORNEY DOCKET NO.	SERIAL NO.
7784-000425DVA	10/717,354
APPLICANT	
Minas H. Tanielian	
FILING DATE	GROUP : 3729
November 19, 2003	Not Yet Assigned

U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/Subclass	(If appropriate) Filing Date
1.	TN	5,632,841	5/27/1997	Hellbaum et al.		
2.		5,849,125	12/15/1998	Clark		
3.	TN	6,162,313	12/19/2000	Bansemir et al.		

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
1.	TN	2001 Face International Corporation, "Thunder White Paper", February 21, 2001, Pgs 1-10

Examiner:

Van Nguyen

Date Considered:

6/28/04

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